FB 1 2 2004 IS

Certification under 37 CFR 1.8(a)

D)	ereby	certify	y that this	paper (along with	any pa	per referre	ed to as	being	attached	d or enclo	sed) is bein	g deposit	ed with
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Vangelis Economou

Name

Haugh Economon

DOCKET: CU-2765

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

APPLICANT:

Sang lck LEE et al

SERIAL NO:

09/994,284

Group Art Unit: 2823

FILING DATE:

November 26, 2001

Examiner:

Pham, Thanh V.

TITLE:

METHOD OF FORMING METAL GATE IN

SEMICONDUCTOR DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR ONE MONTH EXTENSION

Dear Sir:

With reference to the Final Office Action dated October 7, 2003 and the Advisory Action dated January 30, 2004, applicant respectfully requests a one month extension of the term for response, from January 7, 2004 up to a new term of February 7, 2004.

Our enclosed check includes the amount of \$110 to cover the fee for this one month extension. Should any additional fee be deemed necessary, the Commissioner is authorized to charge our Deposit Account No. 12-0400.

02/13/2004 DTESSEM1 00000089 09994284

03 FC:1251

110.00 OP

February 9, 2004

Date

/9

Respectfully submitted,

Attorney for Applicant

Vangelis Economou, Reg. 32341 c/o Ladas & Parry 224 South Michigan Avenue

Chicago, Illinois 60604

(312) 427-1300